

IN THE
UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s): Simon Dodd

Confirmation No.: 5019

Application No.: 09/932,055

Examiner: L.T. Umez-Eronini

Filing Date: August 16, 2001

Group Art Unit: 1765

Title: THERMAL INKJET PRINthead PROCESSING WITH SILICON ETCHING

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

TRANSMITTAL LETTER FOR RESPONSE/AMENDMENT

Sir:

Transmitted herewith is/are the following in the above-identified application:

- (X) Response/Amendment () Petition to extend time to respond
() New fee as calculated below () Supplemental Declaration
() No additional fee (Address envelope to "Mail Stop Non-Fee Amendment")
() Other: (fee \$)

CLAIMS AS AMENDED BY OTHER THAN A SMALL ENTITY						
(1) FOR	(2) CLAIMS REMAINING AFTER AMENDMENT	(3) NUMBER EXTRA	(4) HIGHEST NUMBER PREVIOUSLY PAID FOR	(5) PRESENT EXTRA	(6) RATE	(7) ADDITIONAL FEES
TOTAL CLAIMS	26	MINUS	26	= 0	X \$18	\$ 0
INDEP. CLAIMS	7	MINUS	7	= 0	X \$86	\$ 0
[] FIRST PRESENTATION OF A MULTIPLE DEPENDENT CLAIM					+ \$290	\$ 0
EXTENSION FEE	1ST MONTH \$110.00	2ND MONTH \$420.00	3RD MONTH \$950.00	4TH MONTH \$1480.00		\$ 0
OTHER FEES						\$
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT						\$ 0

Charge \$ 0 to Deposit Account 08-2025. At any time during the pendency of this application, please charge any fees required or credit any overpayment to Deposit Account 08-2025 pursuant to 37 CFR 1.25. Additionally please charge any fees to Deposit Account 08-2025 under 37 CFR 1.16 through 1.21 inclusive, and any other sections in Title 37 of the Code of Federal Regulations that may regulate fees. A duplicate copy of this sheet is enclosed.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, Alexandria, VA 22313-1450.

Date of Deposit: 10/13/2004

Typed Name: Rachel Carter

Signature: Rachel Carter

Respectfully submitted,

Simon Dodd

By

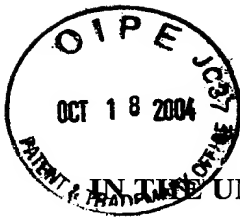
Ketan S. Vakil

Ketan S. Vakil, Esq.

Attorney/Agent for Applicant(s)

Reg. No. 43, 215

Date: 10/13/2004



Patent
10007744-1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Simon Dodd

Application No.: 09/932,055

Filed: August 16, 2001

For: THERMAL INKJET PRINthead
PROCESSING WITH SILICON
ETCHING

Examiner: Lynette T. Umez-Eronini

Group Art Unit: 1765

AMENDMENT AND RESPONSE TO THE OFFICE ACTION

MAIL STOP AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action of August 6, 2004, please amend the above-identified application as follows: